Search Notes				

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/854,463	HANNUKSELA ET AL.	
Examiner	Art Unit	
Erick Rekstad	2621	

SEARCHED			
Class	Subclass	Date	Examiner
375	240.27 240.01 240.13 240.25		ER
386	117		ER
382	232		ER
348	14.01		ER
348	14.02		ER
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
375	240.25	5/27/2005	ER
375	240.27	11/14/2005	ER

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
IEEE: error <and> concealment <and> video</and></and>	5/27/2005	ER	
IEEE, ACM Digital Library, CiteSeer, Optics Information Database search for (h.263 and supplemental enhancement)	11/14/2005	ER	
keyword search	7/21/2004	ER	
keyword search	5/27/2005	ER	
keyword search	11/14/2005	ER	
keyword search	9/1/2006	ER	
keyword search	12/10/2006	ER	
PLUS search	4/20/2007	ER	

Search	Notes (	continued)

Application/Control No.	Applicant(s)/Patent und Reexamination	ler
09/854,463	HANNUKSELA ET AL	
Examiner	Art Unit	
Frick Rekstad	2621	

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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
keyword search	9/14/2007	ER	
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